

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination MAKSIMCHUK ET AL.	
		Examiner John Richardson	Art Unit 3641	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,433,495	08-2002	Wiberg, Peter	315/502
	B	US-6,130,926	10-2000	Amini, Behrouz	376/194
	C	US-5,737,376	04-1998	Hirose, Masafumi	376/194
	D	US-5,789,876	08-1998	Umstadter et al.	315/507
	E	US-5,586,153	12-1996	Alvord, C. William	376/196
	F	US-5,280,505	01-1994	Hughey et al.	376/156
	G	US-5,247,177	09-1993	Goldberg et al.	250/358.1
	H	US-5,037,602	08-1991	Dabiri et al.	376/198
	I	US-4,654,183	03-1987	Hershcovitch, Ady	376/130
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2002-107494(translatio	09-2000	Japan	Nemoto et al	G21G
	O	CA2325362	11-2000	Canada	Maksimchuk et al	G21B
	P	DE004402774	07-1994	Germany	Schulte	G21G
	Q	GB 2237139	10-1990	GB	Koller	G21B
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Maksimchuk et al, "Forward Ion acceleration in thin films driven by a high-intensity laser", Physical Review Letter, May 01 2000 (received for publication September 03 1999), pp. 4108-4111.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.